

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10817396			
<b>Filing Date:</b>	02-Apr-2004			
<b>Title of Invention:</b>	VAPORIZING REACTANT LIQUIDS FOR CHEMICAL VAPOR DEPOSITION FILM PROCESSING			
<b>First Named Inventor:</b>	Visweswaren Sivaramakrishnan			
<b>Filer:</b>	Chang Kim/Barbara Holt			
<b>Attorney Docket Number:</b>	203.73 (AMAT NO.301D2)			
Filed as Large Entity				
<b>Utility Filing Fees</b>				
<b>Description</b>	<b>Fee Code</b>	<b>Quantity</b>	<b>Amount</b>	<b>Sub-Total in USD(\$)</b>
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1400	1400
Publication fee for republication	1505	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Total in USD (\$)				1700